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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/718,381	11/20/2003	Herve Y. Kermel	FIS920030193US1 (16928)	FIS920030193US1 (16928) 9525	
23389 7:	23389 7590 07/11/2005			EXAMINER	
SCULLY SCOTT MURPHY & PRESSER, PC 400 GARDEN CITY PLAZA SUITE 300 GARDEN CITY, NY 11530			LINDSAY JR, WALTER LEE		
			ART UNIT	PAPER NUMBER	
			2812		

DATE MAILED: 07/11/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
Office Action Commons	10/718,381	KERMEL ET AL.			
Office Action Summary	Examiner	Art Unit			
	Walter L. Lindsay, Jr.	2812			
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply					
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).					
Status					
1) Responsive to communication(s) filed on					
• • • • • • • • • • • • • • • • • • • •					
3) Since this application is in condition for allowar	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is				
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.			
Disposition of Claims					
4)⊠ Claim(s) <u>1 and 4-17</u> is/are pending in the application.					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.					
6)⊠ Claim(s) <u>1 and 4-9</u> is/are rejected.					
	Claim(s) is/are objected to.				
8) Claim(s) are subject to restriction and/or	election requirement.				
Application Papers					
9) The specification is objected to by the Examiner.					
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).					
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.					
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some * c) None of:					
<ul> <li>1. Certified copies of the priority documents have been received.</li> <li>2. Certified copies of the priority documents have been received in Application No</li> </ul>					
<ul> <li>2. Certified copies of the priority documents have been received in Application No</li> <li>3. Copies of the certified copies of the priority documents have been received in this National Stage</li> </ul>					
application from the International Bureau (PCT Rule 17.2(a)).					
* See the attached detailed Office action for a list of the certified copies not received.					
Attachment(s)					
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 4) Interview Summary (PTO-413) Paper No(s)/Mail Date					
<ul> <li>2) Notice of Draftsperson's Patent Drawing Review (PTO-948)</li> <li>3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)</li> <li>Paper No(s)/Mail Date</li> </ul>		atent Application (PTO-152)			

### **DETAILED ACTION**

This Office Action is in response to an Amendment filed on 5/3/2005.

Currently, claims 1, 4-17 are pending. Claims 10-17 have been withdrawn from consideration.

## Specification

1. The specification has not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

## Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:
  - 1. Determining the scope and contents of the prior art.
  - 2. Ascertaining the differences between the prior art and the claims at issue.
  - 3. Resolving the level of ordinary skill in the pertinent art.
  - 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

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4. Claims 1 and 4-9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kim et al. (Derwent-ACC-No 2002-178025 published 8/21/2001 the detailed Abstract) in view of Fleming et al. (U.S. Patent No. 6,290,859 dated 9/18/2001).

Kim shows the method substantially as claimed in Figs. 1-10 and corresponding text as: a process of removing residue from a complementary metal oxide semiconductor (CMOS) device which includes a tungsten gate conductor (22) which has been subject to stack etch/ion implantations and photoresist stripping steps comprising the step of contacting a CMOS device which includes a tungsten gate conductor with a cleaning composition comprising sulfuric acid and hydrogen peroxide, (Found in the Detailed Description and Advantage) (claim 1). Kim shows the teaching that the cleaning composition consists essentially of sulfuric acid and hydrogen peroxide (Detailed Description) (claim 9).

Kim lacks anticipation of explicitly teaching that: 1) the sulfuric acid and hydrogen peroxide in a volume ratio in the range of between about 6:1 and about 10:1, the contact occurring at atmospheric pressure and a temperature of between 70°C and about 90°C (claim 1); 2) the volume ratio of sulfuric acid to hydrogen peroxide about 8:1 (claim 4); 4) the contact of said composition with said CMOS device occurs over a period of between about 1 minute and about 10 minutes (claim 5); 5) the period of time is in the range of between about 2 minutes and about 5 minutes (claim 6); 6) the sulfuric acid and hydrogen peroxide are pre-mixed, whereby said cleaning composition is formed (claim 7) and 7) the sulfuric acid and the hydrogen peroxide are in-situ mixed, whereby said cleaning composition is formed (claim 8).

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Fleming teaches a method of applying sulfuric acid and hydrogen peroxide to a device substrate. The surfaces of the device are cleaned with a sulfuric acid mixed with hydrogen peroxide in a range of 5:1 sulfuric acid: hydrogen peroxide to 10:1 sulfuric acid: hydrogen peroxide in a temperature range of 60-130°C for a time duration 0.5-10 minutes (col. 8, line 49- col. 9, line 10). The advantages of using such a method is to substantially remove any organic material from the semiconductor surfaces (col. 4, lines 30-35) and that this process is well known for removing photoresist residue from integrated circuits (i.e. a "de-scum" process) (col. 9, lines 5-10).

It would be obvious to one of ordinary skill in the art, at the time the invention was made, to modify the method described in Kim by implementing the contact of the sulfuric acid and hydrogen peroxide at atmospheric pressure and a temperature of between 70°C and about 90°C, as taught by Fleming, with the motivation that Fleming teaches that the process will substantially remove any organic material from the semiconductor surfaces and is well known for removing photoresist residue from integrated circuits (i.e. a "de-scum" process).

## Response to Arguments

5. Applicant's arguments filed 5/3/2005 in Application No. 10/718381 have been fully considered but they are not persuasive. The examiner has used the Derwent Abstract in keeping with the teachings of the Abstract. The Abstract states that this process is carried out on a semiconductor device, this statement includes CMOS devices. In regard, to the Fleming reference the ratio discussed is in relation to a solution. The piranha etch, is well known in the art of removing contaminates from the

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surface of materials, so as stated above the combination of Kim and Fleming is obvious to one of ordinary skill in the art.

#### Conclusion

6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Walter L. Lindsay, Jr. whose telephone number is (571) 272-1674. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael S. Lebentritt can be reached on (571) 272-1873. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

MICHAEL LÉBENTRITT

Walk Z. Tulls for July 7, 2005